

	<i>Complete if known</i>	
	Application Number: 09/728,896	
	Filing Date: December 1, 2000	
	First Named Inventor: Steinberg, et al.	
	Group Art Unit: 2877 2883	
Examiner Name: Michael P. Mooney		Attorney Docket Number: Shipley 03-05
SHEET 1 OF 1		

UNITED STATES PATENT DOCUMENTS				
EXAMINER'S INITIALS	CITE NO.	PATENT NUMBER	ISSUE DATE MM-DD-YYYY	FIRST NAMED INVENTOR

FOREIGN PATENT DOCUMENTS					
EXAMINER'S INITIALS	CITE NO.	DOCUMENT NUMBER	COUNTRY OR REGION	DATE OF PUBLICATION MM-DD-YYYY	FIRST NAMED INVENTOR OR APPLICANT
MPM	B1	JP6385522	Japan	04/16/1988	Shinji Nagasawa, et al.

OTHER PRIOR ART - NON-PATENT DOCUMENTS		
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in Capital Letters), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published

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EXAMINER'S SIGNATURE	<i>Mich P. Mooney</i>	DATE CONSIDERED	1/16/04
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw a line through citation if citation not in conformance and reference not considered. Include a copy of this form with next communication to applicant.

INFORMATION DISCLOSURE STATEMENT

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EXAMINER'S INITIALS	CITE NO.	PATENT NUMBER	ISSUE DATE MM-DD-YYYY	FIRST NAMED INVENTOR
MPM		4725114	02/16/1988	Murphy
		4973127	11/27/1990	Cannon, Jr. et al.
		5044711	09/03/1991	Saito
		5185825	02/09/1993	Shigematsu et al.
		5357590	10/18/1994	Auracher
		5500911	03/19/1996	Roff
		6320997	11/20/2001	Dautartas et al.
		6477303	11/05/2002	Witherspoon
		6519382	02/11/2003	Jurbergs et al.
		2001/0041026	11/15/2001	Steinberg et al.
MPM		2003/0108272	06/12/2003	Sherrer et al.

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SIGNATURE

Michael P. Mooney

DATE
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**INFORMATION
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STATEMENT***Complete if known*

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<i>mpm</i>		JP1998305151A	Japan	11/05/1999	Tetsu Iwashima

OTHER PRIOR ART - NON-PATENT DOCUMENTS

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EXAMINER'S SIGNATURE	<i>Michael P. Mooney</i>	DATE CONSIDERED	<i>1/24/04</i>
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